

Application/Control No.	Applicant(s)/Patent ur Reexamination	nder
10/609,291	JACKSON ET AL.	
Examiner	Art Unit	
Harold Kim	2181	

SEARCHED				
Class	Subclass	Date	Examiner	
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USPAT, USPGPUB, JPO, EPO, IEEE, NPL, see attached search note; inventor search on dDAN	5/11/2006	НК

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